

APR 0 7 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re application of: HO et al.

Attorney Docket No.: LAM1P152D1/P0692D

Application No.: 10/762,969

Examiner: VINH, Lan

Filed: January 21, 2004

Group: 1765

Title: USE OF AMMONIA FOR ETCHING

ORGANIC LOW-K DIELECTRICS

Confirmation No. 6351

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on April 5, 2006 in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signed:

Sue Funchess

INFORMATION DISCLOSURE STATEMENT BEFORE FINAL ACTION OR NOTICE OF ALLOWANCE (37 CFR §§ 1.56 AND 1.97(c))

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The reference listed in the attached PTO Form 1449, a copy of which is attached, may be material to examination of the above-identified patent application. Applicants submit this reference in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make this citation of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that this reference indeed constitutes prior art.

This Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits, or after three months of the filing date of this application, whichever event occurred last, but it is believed before the mailing date of either: (i) a final action under §1.113 or (ii) a notice of allowance under §1.311, whichever occurs first.

Accompany	ing this Information Disclosure Statement is
\boxtimes	a statement as specified in 37 CFR 1.97(e); or
	the fee set forth in 37 CFR 1.17(p).

The undersigned hereby states that each item of information contained in the Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of the Information Disclosure Statement.

If it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0388 (Order No. LAM1P152D1).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

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Form 1449 (Modified)	Atty Docket No.	Application No.:
	LAM1P152D1/P0692D	10/762,969
Information Disclosure	Applicant:	
Statement By Applicant	HO et al.	
	Filing Date	Group
(Use Several Sheets if Necessary)	January 21, 2004	1765

APR 0 7 7006

U.S. Patent Documents

	O.S. I atent Documents						
Examiner Initial						Sub-	Filing
fnitial	No.	Patent No.	Date	Patentee	Class	class	Date
	A1.						
	A2.						
	A3.						'
	A4.						
	A5.						
	A6.						
	A7.						
	A8.						
	A9.						
	A10.						

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication			Sub-	Trans	lation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	B1.							
	B2.							
	B3.							,
	B4.							
	B5.							

Other Documents

Examiner		
Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1.	First Office Action issued on January 13, 2006 from the Patent Office of the
L		People's Republic of China, including 12 pages of English Translation
	C2.	
	,	

Examiner	Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.